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## IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

: EXAMINER: ARANCIBIA, M.

TETSUO SUZUKI, ET AL. SERIAL NO: 10/677,309

FILED: OCTOBER 3, 2003

: GROUP ART UNIT: 1763

FOR: METHOD OF RECLAIMING

SILICON WAFERS

## REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action dated March 12, 2007, Applicants request reconsideration in view of the following Remarks.

Amendments begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

Arguments begin on page 7 of this paper.

08/13/2007 MAHMED1 00000018 10677309 100.00 OP 01 FC:1202